

Appl. No. : 09/654,845 Confirmation No. 6844  
Applicant : Jifa Hao, et al.  
Filed : September 1, 2000 Art Unit: 2811  
Title : POWER SEMICONDUCTOR DEVICE WITH HIGH AVALANCHE CAPABILITY AND PROCESS FOR FORMING SAME  
Examiner : Ori Nadav  
Docket No. : 87552.99R272 (17732.6323)  
Customer No. : 44,331

Entered  
C/RCE  
4/6/04

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

### **RESPONSE TO OFFICE ACTION**

Sir:

Responsive to the November 1, 2006 Office Action, Applicants submit the following Amendment:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

~~OIC to enter~~  
~~D.N.~~ 1/22/07